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## \*BIBDATASHEET\*

CONFIRMATION NO. 1631

Bib Data Sheet

<b>SERIAL NUMBER</b> 10/707,632	<b>FILING OR 371(c) DATE</b> 12/26/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2813	<b>ATTORNEY DOCKET NO.</b> 12398-US-PA
<b>APPLICANTS</b> SHUN-LI LIN, HSINCHU, TAIWAN; YUN CHU LIN, HSINCHU, TAIWAN; WEN CHUNG CHANG, HSINCHU, TAIWAN; CHING YI LEE, HSINCHU, TAIWAN;				
<b>** CONTINUING DATA *****</b> None / TSP				
<b>** FOREIGN APPLICATIONS *****</b> None / TSP				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 03/11/2004</b>				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <u>Allowance</u> Verified and Acknowledged <u>SSP</u> Examiner's Signature Initials		<b>STATE OR COUNTRY</b> TAIWAN	<b>SHEETS DRAWING</b> 3	<b>TOTAL CLAIMS</b> 13
				<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> AIR MAIL 31561				
<b>TITLE</b> Structure applied to a photolithographic process and method for fabricating a semiconductor device				
<b>FILING FEE RECEIVED</b> 870	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	